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APPLICANTS

Yasuo Kobayashi, Yamanashi-Ken, JAPAN;
 Kohei Kawamura, Yamanashi-Ken, JAPAN;
 Tadahiro Ohmi, Miyagi-Ken, JAPAN;
 Akinobu Teramoto, Miyagi-Ken, JAPAN; *RSP*
 Tatsuya Sugimoto, Tokyo-To, JAPAN;
 Toshiro Yamada, Tokyo-To, JAPAN;
 Kimiaki Tanaka, Tokyo-To, JAPAN;

**** CONTINUING DATA *******

This application is a 371 of PCT/JP04/11595 08/12/2004 *RSP*

**** FOREIGN APPLICATIONS *******

JAPAN 2003-293739 08/15/2003

JAPAN 2003-293862 08/15/2003 *RSP*

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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met. <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Initials <i>RSP</i>				

ADDRESS

441

TITLE

Semiconductor device, method for manufacturing semiconductor device and gas for plasma cvd

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